TION DISCLOSURE STATEMENT BY APPLICANTS **PTO FORM 1449**

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APPLICANT(s)

Frank FISCHER et al.

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GROUP 1763

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
M	5,985,164	Nov. 16, 1999	Chu et al.			

FOREIGN PATENT DOCUMENTS

		TRANSLATION	
ASS SUB-	YES	NO	
33.00	X*	<u> </u>	
	N/A	 	
_	CLASS	CLASS X*	

English Abstract provided.

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
12	B. Li, et al., "Germanium as a Versatile Material for Low-Temperature Micromachining", Journal of Microelectromechanical Systems, IEEE Inc. New York, Vol. 8, No. 4, December 1999, pgs. 366-372

EXAMINER	Nolut.	11	Collit	DATE CONSIDERED	10/12/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.